



SA	C	MICHELLE D. SHINN, "High Average Power Free-Electron Lasers – A New Laser Source For Materials Processing, Thomas Jefferson National Accelerator Facility, Newport News, VA, August 2000	
SA	D	CIRCUIT TECHNOLOGY CENTER, "Techniques For Removing Solder Mask", as found at mhtml:file://C:\WINNT\Temp\MXLibDir\Feature%20-%204%20Techniques%20for%20R. published 2001	

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EXAMINER	Shamim Ahmed	DATE CONSIDERED	9/3/05
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.